

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Cheng Guo et al.

SERIAL NO.: Not yet assigned

FILED: March 5, 2004

FOR: STRUCTURES USEFUL IN ELECTRON
BEAM LITHOGRAPHY

§ GROUP ART UNIT: 1756
§ (Parent Application)
§
§ EXAMINER: S. R. Mohamedulla
§ (Parent Application)
§
§
§ Attorney Docket No.:
§ AM-5264.D1

Date: March 3, 2004

PRELIMINARY AMENDMENT "A"

Hon. Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

Sir:

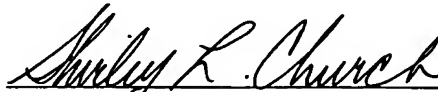
This Preliminary Amendment "A" accompanies a divisional application of U.S. Application
Serial No. 09/698,706, filed October 27, 2000.

Please amend the application as follows:

CERTIFICATE OF MAILING UNDER 37 CFR § 1.10

I hereby certify that this paper is being deposited with the U.S. Postal Service on the date shown below with sufficient postage as U.S. EXPRESS MAIL NO. ER534274308US in an envelope addressed to: Mail Stop Patent Application, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date: March 3, 2004


Shirley L. Church, Reg. No. 31,858

IN THE TITLE:

At page 1, line 1, please delete the Title in its entirety, and replace with the following Title:

-- STRUCTURES USEFUL IN ELECTRON BEAM LITHOGRAPHY --